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Method For Shaping Materials With Plasma-Inducing

APPLICANT:

ীপুরির Kratzsch et al.

SERIAL NO.: FILING DATE WANGON 09/807,061 07/09/01

TITLE:

High-Energy Radiation 2881

GROUP: EXAMINER DOCKET NO

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Assistant Commissioner For Patents Washington, D.C. 20231

Attention: Official Draftsman

Sir:

ant Commissioner For Patents
Ington, D.C. 20231

IONION OFFICIAL DRAWINGS

Enclosed please find formal drawings consisting of six (6) figures on five (56) sheets, for filing in connection with the above-identified application.

Acceptance of the enclosed drawings is respectfully requested.

In the event that any fee is required to be paid in connection with the present submission of formal drawings, please charge the cost of the same to Deposit Account No. 16-0221.

A duplicate copy of this letter is enclosed for the convenience of the Patent and Trademark Office.

Thank you.

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL. POSTAGE PREPAID. IN AN ENVELOPE ADDRESSED TO: ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231, ON: 25 (DATE OF DEPOSIT) Mark J. Pandiscio (NAME OF ATTORNEY) 4/25/02 25/02 bawc:patforms (DATE OF SIGNATURE) stur35dr.ltr

Respectfully submitted,

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